



Attorney's Docket No.: 042390.P4222D2

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Patent  
Technology Center 2800  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Robert S. Chau, et al.

Application No:09/654,315

Filed: September 1, 2000

For: DEVICE STRUCTURE AND METHOD  
FOR REDUCING SILICIDE  
ENCROACHMENT

Examiner: Tran, T.F.

Art Unit: 2811

Commissioner for Patents  
Washington, D.C. 20231

#8/Ext 3 times  
Mount B  
V.A. Edwards  
10/28/02  
Armed

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed April 1, 2002, Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner of Patents, Washington, D.C. 20231

on October 1, 2002  
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Teresa Edwards

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Signature

October 1, 2002

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10/11/2002 EHAILE1 00000038 09654315

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Serial No.: 09/654,315